## **Etch-pit formation-a convective diffusion process**

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Etch-pit formation is one of the numerous physical phenomena which can be understood as convective diffusion processes. The general theory of such processes is given by Levich (Levich 1962 : see also Daccord 1987). Preliminary investigations in this direction were carried out by the present authors a few years ago.

We begin by writing down the differential equations for convective-diffusion processes ( $\nu$  is the fluid velocity, c the concentration of the etchant, other symbols are standard) :

$$
\frac{\partial \mathbf{v}}{\partial t} + (\mathbf{v} \cdot \mathbf{v})\mathbf{v} = -\frac{\nabla \mathbf{p}}{\rho_{\text{sol}}} + \nu \mathbf{v}^2 \mathbf{v}
$$
 (Navier-Stokes eqn.) (1)  

$$
\frac{\partial c}{\partial t} + (\mathbf{v} \cdot \mathbf{v})c = D \mathbf{v}^2 c
$$
 (eqn. for convective diffusion) (2)

We choose a coordinate system with origin at the vertex of the pit in the SSNTD. The track will be assumed to be perpendicular to the flat surface of the detector, and the  $(+)$  ve direction of the Z-axis oriented back along the track. We can now specify the boundary conditions :

(i) 
$$
c \longrightarrow c_0
$$
  
\n $(z \to \infty)$   
\n(ii)  $D\left(\frac{\partial c}{\partial n}\right) = Kc$ , on the reaction front (walls of the pit),

where

$$
K = K_{\rm o}[1 + \alpha l],
$$

 $I=I(\vec{r}, t)$  = ionization density in the detector, and  $K_0$ ,  $\le$  are two constants.

An approximate solution of this convective-diffusion problem can be worked out in the quasi-stationary limit:

$$
\frac{\partial \mathbf{v}}{\partial t} \simeq 0, \frac{\partial c}{\partial t} \simeq 0. \tag{3}
$$

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Actually, inside the pit,  $v \approx 0$ , since the track etch rate  $V_t \sim$  few  $\mu m/hr$ .

Thus we are essentially left to solve the differential eqn.  $\sigma^2 c = 0$ . i.e.,

$$
\frac{\partial^2 c}{\partial \rho^2} + \frac{1}{\rho} \frac{\partial c}{\partial \rho} + \frac{\partial^2 c}{\partial z^2} = 0
$$
 (4)

in the cylindrical polar coordinates.

Now, on general physical grounds, we expect a narrow pit, conical in shape in a first approximation. Since a cone is characterized by a constant value of the ratio  $(\rho/z)$ , the following appears to be a plausible solution of the problem :

Eqn. (4) remains unchanged when the variables are transformed as follows;

$$
\rho \to \lambda \rho', \ z \to \lambda z' \tag{5}
$$

In view of this, a solution of eqn. (4) may be sought such that a combination of variables  $\rho$  and z remains unchanged by transformations (5); such a combination is

$$
\eta=\frac{\rho}{\mathbf{z}}
$$

Setting  $c = c(\eta)$ , we can write eqn. (4) in the form

$$
(1+\eta^2)\frac{d^2c}{d\eta^2}+\left(2\eta+\frac{1}{\eta}\right)\frac{dc}{d\eta}=0
$$

This equation can be solved easily (for  $\eta > 0$ ). We have

$$
\frac{dc}{d\eta} = \frac{A}{\eta(1+\eta^2)^{1/2}} = \frac{Az^2}{\rho(\rho^2+z^2)^{1/2}}
$$

where  $A(\langle 0 \rangle)$  is to be fixed from the boundary condition (ii).

Finally, for fixed z,

$$
c(\rho, z) = c(\eta) - \int_{\eta_0}^{\eta} \left(\frac{dc}{d\eta}\right) d\eta + c(\eta_0) \left[\rho_0 \geq 0.1 \ \mu m\right]
$$

Now the rate *(dR;dt)* at which the radius (R) of the pit, for a given *h* (depth, referred to the point of entry of the particle into the SSNTD), changes with time, is proportional to the diffusional flux rate  $(j_{diff})$  of the etchant on to the surface of the pit. Again

$$
j_{\text{diff}}(R, z) = D \frac{\partial c}{\partial n} \bigg|_{R, s} = -\frac{DA}{R}
$$

and

$$
\frac{dR}{dt} \propto \sqrt{1 + \frac{R^2}{z^2}} \cdot \frac{D |A|}{R}
$$
 (6)

Since, on physical grounds,  $z=\int V_t dt-h$  (where  $V_t$  is the track etch rate) is much larger than R, eqn. (6) reduces to

$$
\frac{dR}{dt}\!\sim\!\frac{1}{R}
$$

Thus

 $R \sim t^{1/2}$  (for fixed h)

Actually, this solution does not correspond exactly to a conical etch pit; but we should remember that a cone is an approximation for the shape of the pit.

If  $\frac{\partial^2 c}{\partial x^2}$  be negligible, then the eqn. for convective-diffusion, near the walls of the pit, can be written as

$$
V_t \frac{\partial c}{\partial z} = D \left( \frac{\partial^2 c}{\partial \rho^2} + \frac{1}{\rho} \frac{\partial c}{\partial \rho} \right) \tag{7}
$$

Scaling arguments show that we may express  $c(\rho, z)$  as a function of  $\zeta = \frac{\rho}{z^{1/2}}$ . This time the differential eqn. (7) reduces to

$$
\frac{d^2c}{d\zeta^2}+\left(k\zeta+\frac{1}{\zeta}\right)\frac{dc}{d\zeta}=0
$$

where

 $k = \frac{V_t}{2D} \leqslant 1.$ 

Thus

$$
\frac{dc}{d\zeta}-\frac{Ae^{-\frac{R}{2}\zeta^2}}{\zeta}
$$

Finally,

$$
\frac{dR}{dt} \propto \frac{1}{z^{1/2}} \left( 1 + \frac{R^2}{4z^2} \right) \frac{dc}{d\zeta}\Big|_{R,s} \xrightarrow{(s>>R)} \frac{dR}{dt} \sim \frac{1}{R}
$$

Consequently we again get

$$
R \sim t^{1/2}
$$
 (at fixed h).

Since  $z \sim t$  (for fixed h), therefore  $R \sim z^{1/8}$ . If the initial boundary condition is something like  $c \simeq 0$  on  $\zeta = \zeta_0$ , i.e.  $c(\zeta_0) \simeq 0$ , then, because  $R \sim z^{1/8}$ ,  $c(\zeta_o) \simeq 0$  at all later times. Thus  $R^2 \simeq \zeta_o^2$  represents the etch pit for large times.

We, therefore, conclude that in either case the etch pit should look somewhat like a paraboloid rather than a cone.

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## **References**

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